

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Takeshi SAKAMOTO et al.)	Confirmation No.: 8322
)	
U.S. Application No.: 10/594,907)	Group Art Unit: 2895
)	
Filed: August 7, 2008)	Examiner: Michael Jung
)	
For: LASER PROCESSING METHOD AND)	
SEMICONDUCTOR CHIP)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the non-final Office Action dated January 29, 2010, the period for response to which extends through July 29, 2010, by the concurrently-filed petition for a three-month extension of time and corresponding fee payment, please amend the above-identified application as follows: